(1) Publication number:

0 055 331

A3

(12)

EUROPEAN PATENT APPLICATION

(21) Application number: 81107584.5

(22) Date of filing: 23.09.81

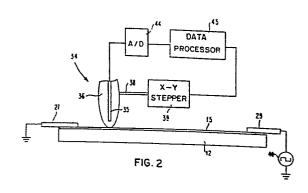
(51) Int. Cl.³: **H 01 C 17/22** G 06 K 11/06

- 30 Priority: 31.12.80 US 221695
- (43) Date of publication of application: 07.07.82 Bulletin 82.27
- 88 Date of deferred publication of search report: 18.05.83
- 84 Designated Contracting States: DE FR GB IT
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- (54) Method of trimming thin metal resistors.
- (5) A thin metal film resistor (15) of a capacitative graphic tablet is trimmed to make the resistor linear within about 0.25%. Alternating voltage is applied along the resistor by a source (40). The resistance of the resistor is measured at discrete points by a capacitative probe (34) and the resistance readings are stored in a data processor (45). A profile is calculated in the processor from the stored readings and a trim operation is made by an electro-erosion apparatus.



Application number

EP 81 10 7584

	DOCUMENTS CONS	IDERED TO BE RELEVAN	Т	
Category		th indication, where appropriate, rant passages	Relevant to claim	CLASSIFICATION OF THE APPLICATION (Int. Ci. 3)
A	DE-A-2 344 504 *Claim 1; page figure 1*	 (SIEMENS A.G.) 4, paragraphs 2-3;	1	H 01 C 17/22 G 06 K 11/06
A	CB-A-1 149 775 SEMICONDUCTOR M LTD.) *Claim 1; page 2, line 42; fig	ANUFACTURERS 1, line 55 - page	1	
A	IBM TECHNICAL D BULLETIN, vol. 1980, pages 666 (USA); J.F.HEVESI: "An *The whole arti	23, no. 2, July -667, New York alog data tablet".	1,6	
D,A	US-A-4 087 625	 (H.DYM et al.)		TECHNICAL FIELDS SEARCHED (Int. Cl. ³)
D,A	FR-A-2 376 399	(IBM CORP.)		H 01 C G 06 K
	The present search report has b	peen drawn up for all claims		
Place of search THE HAGUE Date of completion of the search 01-02-1983		DECANNIERE L.J.		
CATEGORY OF CITED DOCUMENTS X: particularly relevant if taken alone Y: particularly relevant if combined with another document of the same category A: technological background O: non-written disclosure P: intermediate document T: theory or principle underlying the invention E: earlier patent document, but published on, or after the filing date D: document cited in the application L: document cited for other reasons &: member of the same patent family, corresponding document				